Search Notes				

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/670,876	CHEN ET AL.	
Examiner	Art Unit	
lim Vannucci	2828	

SEARCHED				
Class	Subclass	Date	Examiner	
	"			

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	

SEARCH NOTES (INCLUDING SEARCH STRATEGY)			
	DATE	EXMR	
active layer, mesa, ridge waveguide, 372/107	9/8/2005	J۷	